

Device for spraying an etching solution onto a substrate

Abstract

The invention relates to a device for spraying an etching solution onto a peripheral surface of a substrate, comprising:

- at least one nozzle (1) designed to spray said etching solution,
- a nozzle holder (2) that is deformable between an adjusting position, in which the nozzle (1) is able to pivot about an axis (X) of the holder (2), and a fixing position, in which the nozzle (1) is fixed with respect to the holder (2).

Fig. 4